

2814
JFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kusumoto et al.

Art Unit : 2814

Serial No. : 09/903,339

Examiner : Theresa T. Doan

Filed : July 10, 2001

Title : METHOD FOR PRODUCING INSULATED GATE THIN FILM
SEMICONDUCTOR DEVICECommissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450TRANSMITTAL LETTER AND PETITION FOR AUTOMATIC EXTENSION

Correspondence relating to this application is enclosed. The required fees are computed below. Please apply any charges not covered, or any credits, to Deposit Account No. 06-1050.

Total Claims	42	-	30	=	12	\$216
Independent	12	-	9	=	3	\$258
First Presentation of Multiple Dependent Claims						\$0

Applicant hereby petitions under 37 C.F.R. §1.136 for a 2 month extension of time.

\$420

TOTAL FEE DUE

\$894

A check for \$894 is attached.

Respectfully submitted,

Date: 7/12/2004
Joseph F. Key
Reg. No. 44,827Fish & Richardson P.C.
1425 K Street, N.W.
11th Floor
Washington, DC 20005-3500
Telephone: (202) 783-5070
Facsimile: (202) 783-2331

40229388.doc

07/14/2004 WABRHAM1 00000116 09903339

03 FC:1252

420.00 OP